## Presentation

### on

## **Electron Sources**

**Chapter 5** 

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# Two Types of Electron Sources

### **1. Thermionic source**

### **Physics of Thermionic Source**

### WORK FUNCTION

- The work function is the minimum energy needed to remove an electron from a solid to a point immediately outside the solid surface.
- For Tungsten  $\Phi_w$ = 4.5 eV



# **Richardson's Law**

The emitted current density J (A/m<sup>2</sup>) is related to temperature T by the equation:

$$J = AT^2 e^{\frac{-W}{kT}}$$
 W is work function  
A Richardson's constant

$$A = \frac{4\pi m k^2 e}{h^3} = 1.20173 \times 10^6 \quad {\rm A \ m^{-2} \ K^{-2}}$$

Tungsten = 4.5 eVLaB<sub>6</sub> = 2.4 eV

- High temperature heating give higher J but shorten the source life through evaporation/ oxidation.
- Operation at compromising temperature: "Saturation Condition"

### **Saturation Condition**



#### Less than saturation decreases the intensity of the signals

Higher than saturation decreases the life of filament

- **1.** Thermionic source (function)
- An positive electrical potential is applied to the anode
- The filament (cathode) is heated until a stream of electrons is produced
- The electrons are then accelerated by the positive potential down the column
- A negative electrical potential (~500 V) is applied to the Whenelt Cap
- As the electrons move toward the anode any ones emitted from the filament's side are repelled by the Whenelt Cap toward the optic axis (horizontal center)
- A collection of electrons occurs in the space between the filament tip and Wehnelt Cap. This collection is called a space charge
- Those electrons at the bottom of the space charge (nearest to the anode) can exit the gun area through the small (<1 mm) hole in the Whenelt Cap
- These electrons then move down the column to be later used in imaging



#### **Thermionic Gun**



Wehlnet cup

Cathode

Anode



**Figure 5.5.** (A) The tip of a tungsten hairpin filament and the distribution of electrons when the filament is (B) undersaturated and misaligned, (C) undersaturated and aligned, and (D) saturated.



**Figure 5.6.** (A) An LaB<sub>6</sub> crystal and the electron distribution wh source is (B) undersaturated and aligned and (C) saturated.

# Achieving Optimum Beam Current

В

А



**Figure 5.4.** (A) The effect of increasing Wehnelt bias (i-iii) on the distribution of electrons coming through the anode. (B) The relationship between the bias and the emission current/gun brightness. Maximum brightness is achieved at an intermediate Wehnelt bias, and an intermediate emission current [condition (ii) in A].

#### In general beam dia < 0.1 micron

In SEM > we need small probe> no Wehnelt control is not provided In TEM> we may need brighter image> Wehnelt control is not provided

# **Field Emission Sources**

### History of field emission

- The basic mechanism of field emission was discovered in 1897 by Wood, who found that a high voltage applied between a pointed cathode and a plate anode caused a current to flow.
- Hibi first suggested in 1954 that a heated tungsten point, rather than a bent tungsten wire, might produce a smaller source size and higher brightness.
- In 1954, Cosslett and Haine proposed the use of a field emission cathode for electron microscopy. But due to the requirement for an extremely high vacuum (~ 10<sup>-9</sup> Torr), no practical use was made.
- Until 1966, Crewe managed to build a usable system.

# **Field Emission Gun**



Grid (First anode):

provides the extraction voltage to pull electrons out of the tip.

Anode (Second anode): accelerates the electrons to 100 kV or more.

Crossover: is the effective source of illumination for microscope.

# Field emission tip

- In order to obtain high filed strength with low voltages, the field emitting tip has a strong curvature.
- By etching a single crystal tungsten wire to a needle point.
- <310> orientation is found to be the best for emission.
- Emitting region can be less than 10 nm.
- E=V/r If 1kV at tip, E~10<sup>10</sup> V/m





# **Cold & Thermal Field Emission**

- By operating in UHV (<10<sup>-11</sup> Torr), the tungsten tip is operated at ambient temperature.----Cold field emission
- UHV can reduce contamination and oxide.
- If the cathode incorporates both thermionic and field emissions at a poorer vacuum, the thermal energy assists the electron emission.----Thermal field emission.
- 'Schottky' emitter. Normally use ZrO<sub>2</sub> to treat the surface.

## **Advantages of Field Emission Gun**

- Low operating temperature (~300K)
- High brightness (10<sup>13</sup> A/m<sup>2</sup>sr)
- High current density (10<sup>10</sup> A/m<sup>2</sup>)
- Small source size < 0.01 um</li>
- Highly spatially coherent, small energy spread
- Long life time

## **Disadvantages of Field Emission Gun**

- Small source size → Not good for large area specimen, easy lose current density
- The emission current is not as stable as Thermionic emission gun
- Need UHV

# **Comparison of electron guns**

### **Characteristics of Electron Beam**

### **Brightness**

Current density per unit solid angle

$$\beta = \frac{i_e}{\pi \left(\frac{d_0}{2}\right)^2 \pi (\alpha_0)^2} = \frac{4 i_e}{\left(\pi d_0 \alpha_0\right)^2}$$

Units of  $\beta$  is A.cm<sup>-2</sup>sr<sup>-1</sup>

More is  $\beta$ , more is no of electrons/area

More beam damage

Important with fine beams, as in AEM

TEM uses defocused beam

Measured by inserting a Faraday cup



**Figure 5.1.** Schematic diagram of a thermionic electron gun. A high voltage is placed between the filament and the anode, modified by a potential on the Wehnelt which acts to focus the electrons into a crossover, with diameter  $d_0$  and convergence/divergence angle  $\alpha_0$ .

### **Temporal Coherency and Energy Spread**

Monochromatic – 1 wavelength

Temporal coherency – measure of similarity of wave packets.

**Coherence length** 

 $\lambda_c = \frac{\nu h}{\Delta E}$  where h is Planck's constant, v is velocity of the electrons and  $\Delta E$  is the energy spread of the beam

 $\Delta E$  related to stability of accelerating voltage

Typical  $\Delta E$  values are 0.1 – 3eV. Electron energies are up to 400keV

Not much important for imaging

Important in spectroscopy, EELS

 $\Delta E$  measured using an electron spectrometer

 $\Delta E$  is taken as the FWHM of the Gaussian peak obtained

### **Spatial Coherency**

Related to the size of the source

Perfect source – electron emanating from same point

Effective source size for coherent illumination

where  $\boldsymbol{\lambda}$  is the Wavelength and

 $d_c \prec \prec \frac{\lambda}{2\alpha}$  a is angle subtended by source at specimen

d<sub>c</sub> should be as large as possible

 $\boldsymbol{\alpha}$  is limited by source size or aperture size

Small beams are more spatially coherent

Required for good phase contrast and

diffraction patterns

**Convergence Angle Determination** 

$$2\alpha = 2\theta_B \frac{a}{b}$$

 $\alpha$  Important in Brightness calculation, CBED, STEM and EELS

 $\boldsymbol{\alpha}$  controlled by final aperture



**Figure 5.8.** The distances on a convergent-beam diffraction pattern from which you can measure the beam-convergence semiangle,  $\alpha$ , which is proportional to the width of the diffraction disk.

#### **Calculating the Beam Diameter**

$$d_{t} = \left(d_{g}^{2} + d_{s}^{2} + d_{d}^{2}\right)^{1/2}$$
$$d_{g} = \frac{2}{\pi} \left(\frac{i}{\beta}\right)^{2} \frac{1}{\alpha}$$
$$d_{s} = 0.5C_{s}\alpha^{3}$$
$$d_{d} = 1.22\frac{\lambda}{\alpha}$$



**Figure 5.10.** Calculations of the three contributions to the probe size as a function of the convergence semiangle  $\alpha$  in an FEG STEM with a probe current  $I_p$  of  $0.85 \times 10^{-8}$  A. Two experimental measurements are shown, at condenser 1 lens settings 17 and 20. The minimum probe dimension is -1 nm with  $\alpha < 10$  mrads.

d<sub>t</sub> = calculated beam diameter
d<sub>s</sub> = broadening due to spherical aberration
d<sub>d</sub> = broadening due to diffraction



**Figure 5.9.** The definition of the full width at half maximum (FWHM) and the full width at tenth maximum (FWTM) of a Gaussian intensity distribution which is typical of a well-aligned beam.

|                            | Units               | Tungsten          | LaB <sub>6</sub>   | Field Emission |
|----------------------------|---------------------|-------------------|--------------------|----------------|
| Work function, $\Phi$      | eV                  | 4.5               | 2.4                | 45             |
| Richardson's constant      | $A/m^2K^2$          | $6 \times 10^{5}$ | $4 \times 10^{5}$  | 1.0            |
| Operating temperature      | К                   | 2700              | 1700               | 300            |
| Current density            | A/m <sup>2</sup>    | $5 \times 10^4$   | 106                | 1010           |
| Crossover size             | 📲 μm                | 50                | 10                 | < 0.01         |
| Brightness                 | A/m <sup>2</sup> sr | 109               | $5 \times 10^{10}$ | 1013           |
| Energy spread              | eV                  | 3                 | 1.5                | 0.3            |
| Emission current stability | %/hr                | <1                | <1                 | 5              |
| Vacuum                     | Pa                  | 10-2              | 10-4               | 10-8           |
| Lifetime                   | hr                  | 100               | 500                | >1000          |

#### TABLE 5.1. Characteristics of the Three Principal Sources Operating at 100 kV

Tungsten hairpin filament – Robust, Cheap, Easily replaceable

LaB<sub>6</sub> :- Lower work function, More brightness, More coherent, Lower energy spread

Costly, High vacuum required, should be heated and cooled slowly

FEG :- Extremely high Current density, high brightness, small beam size Large areas cannot be viewed, UHV required